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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)	
)	
Wu et al.)	Group Art Unit: 2891
)	
Serial No.: 10/672,778)	Examiner: Smith, Bradley
)	
Filed: September 26, 2003)	Confirmation No.: 9717
)	
For: Atomic Layer Deposition (ALD) Method with)	TKHR Docket: 252016-3000
Enhanced Deposition Rate)	Top-Team: 0503-8501DUS
)	

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR §1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted on the date indicated below via facsimile to the United States Patent and Trademark Office, Technology Group 2100, facsimile number (571) 273-8300. Total number of pages in this transmission 9.

February 14, 2005

Date


Daniel R. McClureAMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed November 29, 2005 has been carefully considered. In further response thereto, please enter the following amendments and consider the following remarks.